

(19) World Intellectual Property Organization
International Bureau



(43) International Publication Date
11 October 2001 (11.10.2001)

PCT

(10) International Publication Number
WO 01/75486 A3

(51) International Patent Classification⁷: F24J 2/10,
B64G 1/50

(US). PAN, Yiqun; 36 Torrey Pines, Clifton Park, NY 12065 (US). WEI, Chang; 1187 Hillside Avenue, #2B14, Niskayuna, NY 12309 (US). CHEN, Mao; 700 Oleander Lane, Evansville, IN 47712 (US).

(21) International Application Number: PCT/US01/09287

(22) International Filing Date: 23 March 2001 (23.03.2001)

(74) Agents: PENNINGTON, Edward, A. et al.; Swidler Berlin Shereff Friedman, LLP, 3000 K Street, N.W., Suite 300, Washington, DC 20007 (US).

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data: 09/540,757 31 March 2000 (31.03.2000) US

(84) Designated States (regional): European patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE, TR).

(71) Applicant: LOCKHEED MARTIN CORPORATION [US/US]; 6801 Rockledge Drive, Bethesda, MD 20817 (US).

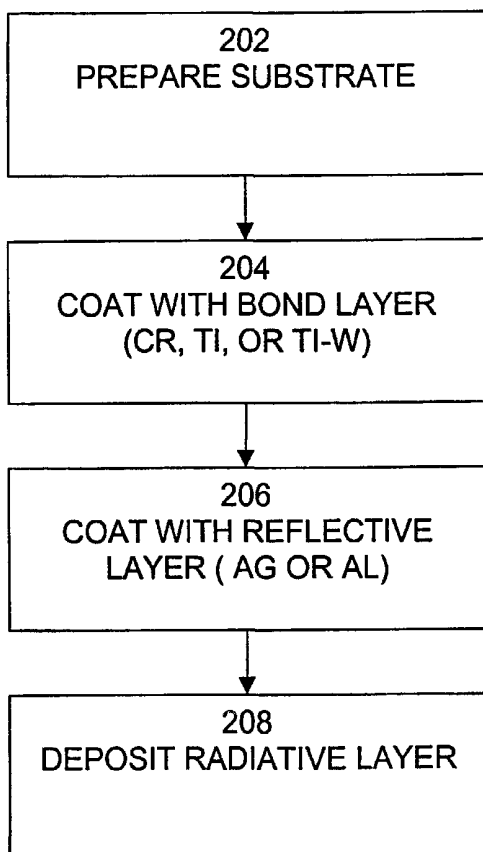
Published:
— with international search report

(72) Inventors: IACOVANGELO, Charles, Dominic; Apartment A27, 1197 Hillside Avenue, Niskayuna, NY 12309

(88) Date of publication of the international search report:
21 March 2002

[Continued on next page]

(54) Title: IMPROVED OPTICAL SOLAR REFLECTORS



(57) Abstract: An method, and method of production thereof, which provides excellent performance, reduced cost, and reduced breakage due to reduced manual handling. The present invention comprises a substrate, a bond layer coating the substrate, a reflective layer coating the bond layer, and a radiative layer coating the reflective layer. Preferably, the radiative layer comprises SiO₂, Si₃N₄ or SiO_xN_y, has low absorberency of electromagnetic radiation having wavelengths of approximately 200 nm to approximately 2500 nm and high absorberency and emissivity electromagnetic radiation having wavelengths of approximately 2.5 μm to approximately 25 μm. Preferably, the bond layer comprises chromium, titanium, or titanium-tungsten and the substrate comprises aluminum, aluminum alloys, polyimide, carbon-filled polyimide, or carbon composite. The present invention may further comprise a barrier layer between the reflective layer and the radiative layer, preferably comprising MgF₂, which improves adhesion between the reflective layer and the radiative layer during thermal cycling. The present invention may further comprise a surface-leveling layer between the substrate and the bond layer, preferably comprising a silicone hardcoat material, which improves surface smoothness of the substrate. The radiative layer may have a modulated refractive index profile. The parameters of the modulated refractive index profile of the radiative layer may control amplitude, bandwidth and wavelength of refection bands of the radiative layer.



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INTERNATIONAL SEARCH REPORT

International Application No PCT/US 01/09287

A. CLASSIFICATION OF SUBJECT MATTER
 IPC 7 F24J2/10 B64G1/50

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
 IPC 7 B64G C03C G02B F24J

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)
 EPO-Internal, COMPENDEX, PAJ

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	MARTIN P M ET AL: "Multilayer coatings and optical materials for tuned infrared emittance and thermal control" PROCEEDINGS OF THE 1998 MRS FALL MEETING - SYMPOSIUM 00, 'PROPERTIES AND PROCESSING OF VAPOR-DEPOSITED COATINGS; BOSTON, MA, USA NOV 30-DEC 2 1998, vol. 555, 30 November 1998 (1998-11-30), pages 3-12, XP001041357 Mater Res Soc Symp Proc; Materials Research Society Symposium - Proceedings 1999 Materials Research Society, Warrendale, PA, USA page 3, line 1 -page 5, line 22	1-3
A	--- -/--	4-6, 44

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° Special categories of cited documents:

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Date of the actual completion of the international search 20 November 2001	Date of mailing of the international search report 28/11/2001
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Name and mailing address of the ISA European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016	Authorized officer <p style="text-align: center; font-weight: bold;">Beltzung, F</p>
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INTERNATIONAL SEARCH REPORT

International Application No

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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT		
Category	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	PATENT ABSTRACTS OF JAPAN vol. 017, no. 330 (M-1434), 23 June 1993 (1993-06-23) -& JP 05 039100 A (ISHIKAWAJIMA HARIMA HEAVY IND CO LTD), 19 February 1993 (1993-02-19) abstract ---	1
X	US 3 174 537 A (MEYER RUDOLF X) 23 March 1965 (1965-03-23) column 7, line 62 -column 8, line 55; figure 6 ---	1
A	---	2-6,25
A	US 5 608 414 A (AMORE LEO J) 4 March 1997 (1997-03-04) column 3, line 15 - line 42; figure 3A ---	1-3
A	PATENT ABSTRACTS OF JAPAN vol. 006, no. 002 (P-096), 8 January 1982 (1982-01-08) -& JP 56 128901 A (TOSHIBA ELECTRIC EQUIP CORP), 8 October 1981 (1981-10-08) abstract ---	1
A	PATENT ABSTRACTS OF JAPAN vol. 017, no. 008 (M-1350), 7 January 1993 (1993-01-07) -& JP 04 238798 A (ISHIKAWAJIMA HARIMA HEAVY IND CO LTD), 26 August 1992 (1992-08-26) abstract ---	1
A	EP 0 918 044 A (GLAVERBEL) 26 May 1999 (1999-05-26) abstract ---	1,17
A	US 5 541 010 A (TANZILLI RICHARD A ET AL) 30 July 1996 (1996-07-30) the whole document ---	1,2
A	EP 0 568 943 A (ALUMINUM CO OF AMERICA) 10 November 1993 (1993-11-10) abstract ---	1,21
A	US 4 850 660 A (JONES DAVID P ET AL) 25 July 1989 (1989-07-25) column 1, line 7 - line 32 column 6, line 13 - line 56 ---	1
A	US 4 189 205 A (VANDEHEI PETER T) 19 February 1980 (1980-02-19) column 2, line 16 -column 4, line 8; figure 2 ---	1-7,17, 18
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INTERNATIONAL SEARCH REPORT

International Application No

PC1/US 01/09287

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT		
Category	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	US 3 671 286 A (FISCHELL ROBERT E) 20 June 1972 (1972-06-20) -----	

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

PCT/US 01/09287

Patent document cited in search report	A	Publication date	Patent family member(s)	Publication date
JP 05039100	A	19-02-1993	JP 3084814 B2	04-09-2000
US 3174537	A	23-03-1965	NONE	
US 5608414	A	04-03-1997	FR 2736213 A1 GB 2302993 A ,B	03-01-1997 05-02-1997
JP 56128901	A	08-10-1981	NONE	
JP 04238798	A	26-08-1992	NONE	
EP 0918044	A	26-05-1999	EP 0918044 A1 AU 1669099 A WO 9925661 A1 EP 1032543 A1 PL 340594 A1	26-05-1999 07-06-1999 27-05-1999 06-09-2000 12-02-2001
US 5541010	A	30-07-1996	NONE	
EP 0568943	A	10-11-1993	EP 0568943 A1	10-11-1993
US 4850660	A	25-07-1989	DE 3725871 A1 GB 2193819 A ,B JP 2694951 B2 JP 63056602 A	11-02-1988 17-02-1988 24-12-1997 11-03-1988
US 4189205	A	19-02-1980	NONE	
US 3671286	A	20-06-1972	NONE	